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<b>TRANSMITTAL FORM</b> <i>(to be used for all correspondence after initial filing)</i>	Application Number	09/632,425
	Filing Date	August 4, 2000
	First Named Inventor	Geiger, Fabrice
	Group Art Unit	2829
	Examiner Name	Lisa A. Kilday
Total Number of Pages in This Submission	Attorney Docket Number	A3024T28300

ENCLOSURES (check all that apply)		
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### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Fabrice Geiger et al.

Application No.: 09/632,425

Filed: August 4, 2000

For: PROCESS FOR DEPOSITING A  
POROUS, LOW DIELECTRIC  
CONSTANT SILICON OXIDE FILM

Examiner: Lisa A. Kilday

Art Unit: 2829

AMENDMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the Office Action mailed February 6, 2002, please amend the above-identified application as follows:

#### IN THE CLAIMS:

Please amend claim 10 as follows. The remaining claims are unamended, but are reproduced below for the Examiner's convenience and reference.

1. A method for forming an insulation layer over a substrate, the method comprising:

forming a surface sensitive silicon oxide layer over the substrate; and

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